

TSMC-00-166



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October 29, 2003

To: Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Fr: George O. Saile, Reg. No. 19,572  
28 Davis Ave  
Poughkeepsie, NY 12603

Subject: | Serial No. 09/679,514

10/06/00

Hung-Jen Hsu

"A METHOD TO IMPROVE PASSIVATION  
OPENINGS BY REFLOW OF PHOTORESIST  
TO ELIMINATE TAPE RESIDUE"

| Grp. Art Unit: 2823

B. KEBEDE |

RESPONSE PATENT OFFICE ACTION

Dear Sir:

In response to the Office Action dated August 8, 2003,  
please amend the above-identified application for patent as  
follows:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being  
deposited with the United States Postal Service as first  
class mail in an envelope addressed to: Commissioner for Patents  
P.O. Box 1450, Alexandria, VA 22313-1450, on November 10,  
2003.

Stephen B. Ackerman, Reg. No. 37,761

Signature

Date 11/10/03

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